

In the claims:

Please amend claims 80, 82, 85, 88, 91, 94, 97, 100 and 103 as follows:

80. (Amended) A multi-chamber system comprising:

a first chamber for irradiating laser light to a semiconductor film formed over a substrate;

a second chamber for depositing a gate insulating film on said semiconductor film;
and

[A] a third chamber capable of taking said substrate out of said multi-chamber system after depositing said gate insulating film.

82. (Amended) A multi-chamber system according to claim 81 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

85. (Amended) A multi-chamber system according to claim 84 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

88. (Amended) A multi-chamber system according to claim 87 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

91. (Amended) A multi-chamber system according to claim 90 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

✓ 94. (Amended) A multi-chamber system according to claim 93 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

✓ 97. (Amended) A multi-chamber system according to claim 96 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

✓ 100. (Amended) A multi-chamber system according to claim 99 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

✓ 103. (Amended) A multi-chamber system according to claim 102 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

Please add new claims 104-123 as follows:

✓ 104. (New) A multi-chamber system according to claim 80 wherein said laser light comprises an excimer laser light.

✓ 105. (New) A multi-chamber system according to claim 80 wherein said laser light has a linear shape.

✓ 106. (New) A multi-chamber system according to claim 83 wherein said laser light comprises an excimer laser light.

112, 2ndTP
105, 107, 109,
112, 115, 117,
119, 122
pg 17, lines
= rectangular
laser

✓ 107. (New) A multi-chamber system according to claim 83 wherein said laser light has a linear shape.

✓ 108. (New) A multi-chamber system according to claim 86 wherein said laser light comprises an excimer laser light.

✓ 109. (New) A multi-chamber system according to claim 86 wherein said laser light has a linear shape.

110. (New) A multi-chamber system according to claim 86 wherein said means for transporting said substrate comprises a robot hand.

✓ 111. (New) A multi-chamber system according to claim 89 wherein said laser light comprises an excimer laser light.

✓ 112. (New) A multi-chamber system according to claim 89 wherein said laser light has a linear shape.

113. (New) A multi-chamber system according to claim 89 wherein said means for transporting said substrate comprises a robot hand.

✓ 114. (New) A multi-chamber system according to claim 92 wherein said laser light comprises an excimer laser light.

✓ 115. (New) A multi-chamber system according to claim 92 wherein said

laser light has a linear shape.

✓ 116. (New) A multi-chamber system according to claim 95 wherein said laser light comprises an excimer laser light.

✓ 117. (New) A multi-chamber system according to claim 95 wherein said laser light has a linear shape.

✓ 118. (New) A multi-chamber system according to claim 98 wherein said laser light comprises an excimer laser light.

✓ 119. (New) A multi-chamber system according to claim 98 wherein said laser light has a linear shape.

120. (New) A multi-chamber system according to claim 98 wherein said means for transporting said substrate comprises a robot hand.

121. (New) A multi-chamber system according to claim 101 wherein said laser light comprises an excimer laser light.

122. (New) A multi-chamber system according to claim 101 wherein said laser light has a linear shape.

123. (New) A multi-chamber system according to claim 101 wherein said means for transporting said substrate comprises a robot hand.